

UNITED STATES DEPARTMENT OF COMMERCE  
PATENT AND TRADEMARK OFFICE

PATENT

In the application:

RECEIVED  
CENTRAL FAX CENTER  
MAR 18 2008

Inventors: HE, Ting et al.  
Serial Number: 10/757,302

Filed: January 14, 2004

For: HIGH THROUGHPUT PHYSICAL VAPOR DEPOSITION SYSTEM  
FOR MATERIAL COMBINATORIAL STUDIES

Group Art Unit 1763  
Examiner Richard R. Bueker

Atty. Docket No.: 3994994-148069

CONFIRMATION NO. 4457

RESPONSE

TO THE NOTICE OF NON-COMPLIANT AMENDMENT MAILED ON OCTOBER 10, 2007

BY FACSIMILE ON MARCH 18, 2008 TO 571-273-8300

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

INTRODUCTORY COMMENTS

To the Honorable Commissioner:

In response to the Notice of Non-Compliant Amendment Mailed on October 10, 2007, claims 11, 12 and 14 are corrected. Pages 5 and 6 of the originally filed Amendment, now including the corrected claims, are resubmitted herewith, attached as the two following pages: